



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takeo KAGAMI et al.

Group Art Unit: 2653

Application No.: 10/600,444

Examiner: A. HEINZ

Filed: June 23, 2003

Docket No.: 116329

For: MAGNETO-RESISTIVE DEVICE WITH
REDUCED SUSCEPTIBILITY TO ION BEAM
DAMAGE (AS AMENDED)

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicants hereby request continued examination.

☒ Applicants further request entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 173979 in the amount of ☒ \$790.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Klifton L. Kime
Registration No. 42,733

JAO:KLK/tbh

Date: December 12, 2005

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12/13/2005 JAO:KLK/tbh	
DEPOSIT ACCOUNT NO. 15-0461	
AUTHORIZATION 790.00 OP	
Please grant any extension necessary for entry;	
Charge any fee due to our	
Deposit Account No. 15-0461	